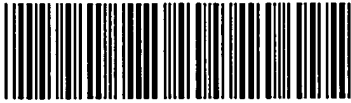


Search Notes

Application/Control No.

10/735,154

Examiner

Edwin A. León

Applicant(s)/Patent under
Reexamination

KO, DAVID (TSO-CHIN)

Art Unit

2833

SEARCHED

Class	Subclass	Date	Examiner
439	607-610	4/8/2005	EAL
	660		
	492-495		
	79		
	571-573		
	629		
	108		
	901		

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR